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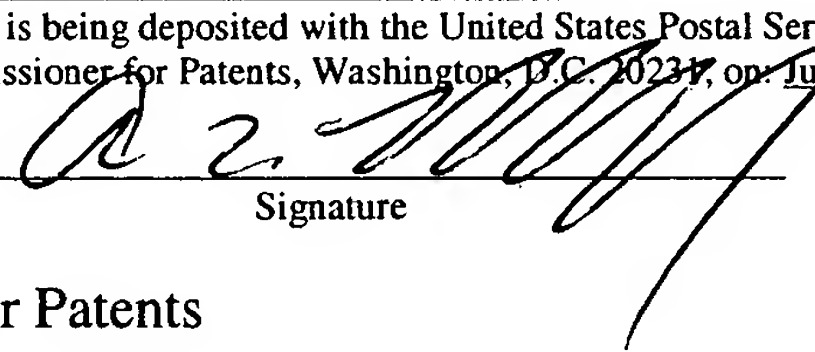
2881 #3
37904-0038

IN THE UNITED STATES AND PATENT AND TRADEMARK OFFICE

Applicant : Hiroyuki Nishimura
Serial No. : 10/076,034
Filed : February 13, 2002
For : METHOD FOR PRODUCING SYNTHETIC QUARTZ
GLASS MEMBERS FOR EXCIMER LASERS AND
SYNTHETIC QUARTZ GLASS MEMBERS FOR
EXCIMER LASER OPTICS PRODUCED BY THE
SAME
Group art unit : 2881
Examiner : unknown

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on: July 15, 2002.

Andrew L. Tiajolloff
Name of Applicant, Assignee
or Registered Representative


Signature

July 15, 2002
Date of Signature

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

S I R :

Applicant submits herewith a PTO form 1449, a copy of the listed reference, and a copy of the recent European search report in which the reference was cited. Entry of this reference in the application file and formal allowance are respectfully requested.

It is not believed that any fee is required for consideration of this reference, but if a fee is required, please deduct it from deposit account 501659.

Should any questions arise, the Examiner is invited to telephone attorney for applicant at 212-351-3447.

Respectfully submitted,

By 

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~~INFORMATION DISCLOSURE CITATION~~

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Applicant(s)

Hiroyuki Nishimura

Filing Date

February 13, 2002

Group Art Unit

2881

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.